Contact Potential Difference Probe A Non-Contact Lubricant Film Sensor



Precision Machining Research Consortium
Industrial Advisory Board
Georgia Institute of Technology
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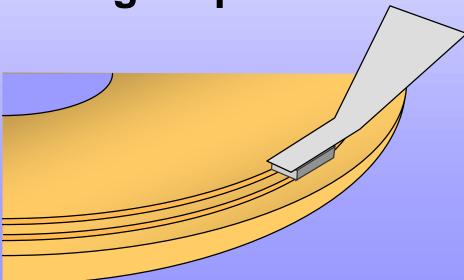
Advisor: Dr. Steven Danyluk

Objective



Development of a non-contact sensor for wear, corrosion, and lubrication monitoring.

(building on prior work of Danyluk group)

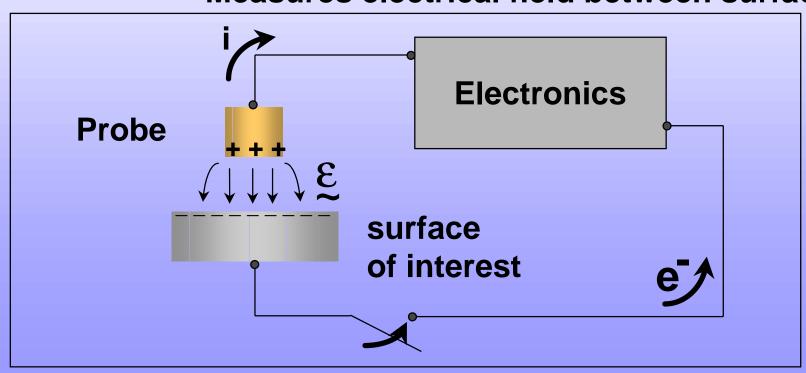


Contact Potential Difference (CPD) Sensor



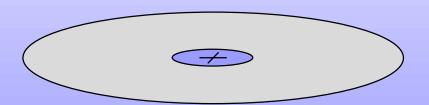
New application of a **Kelvin Probe**

Measures electrical field between surfaces



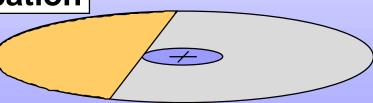


Non-Lubricated Hard Disk

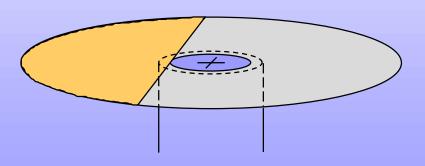




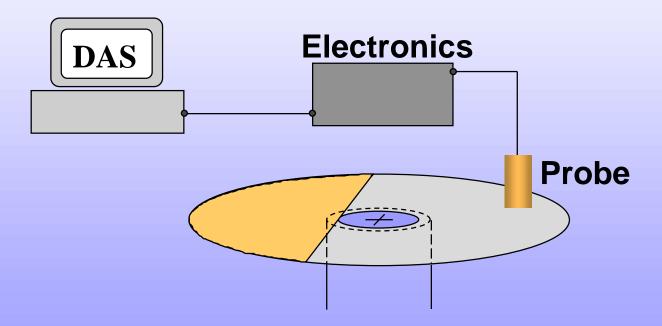
Partial Lubrication



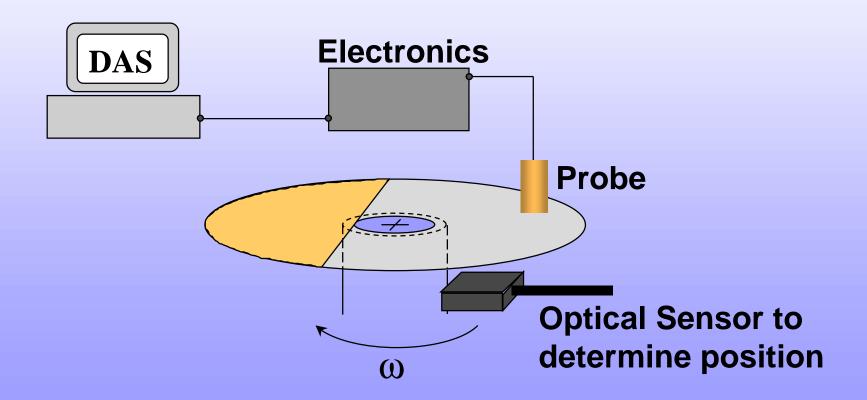




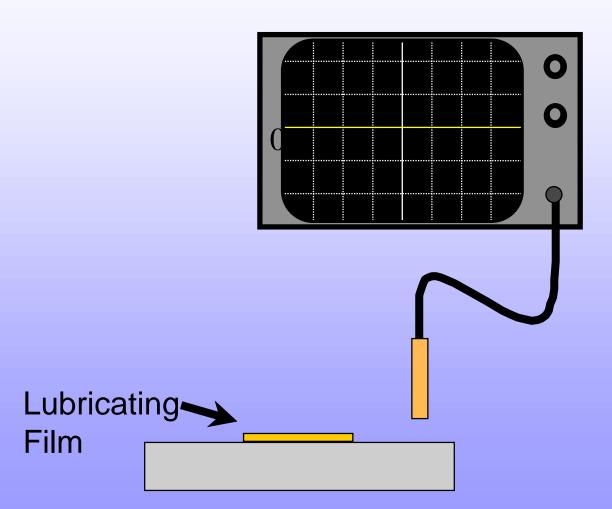




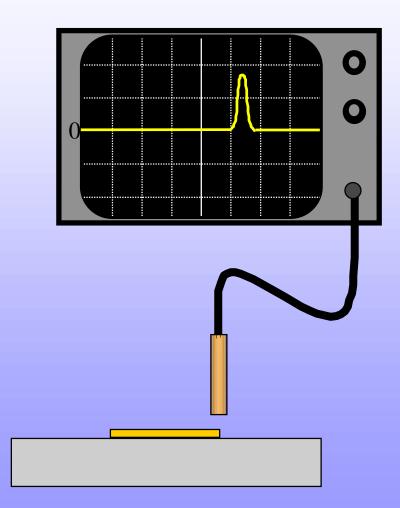




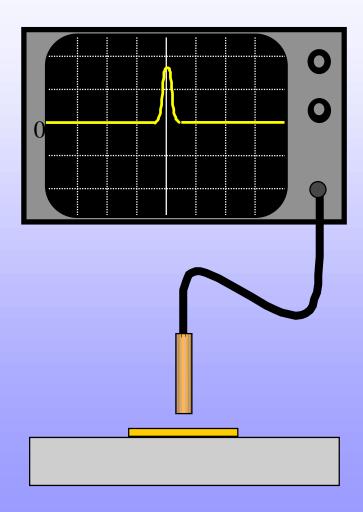




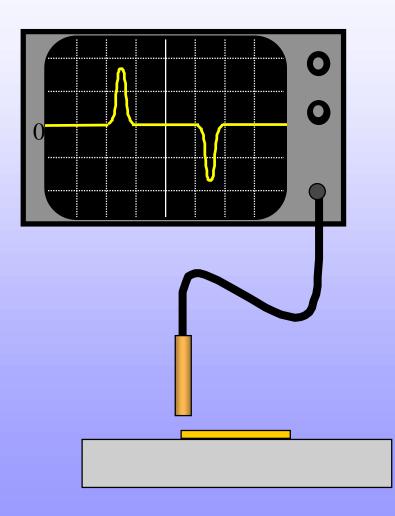




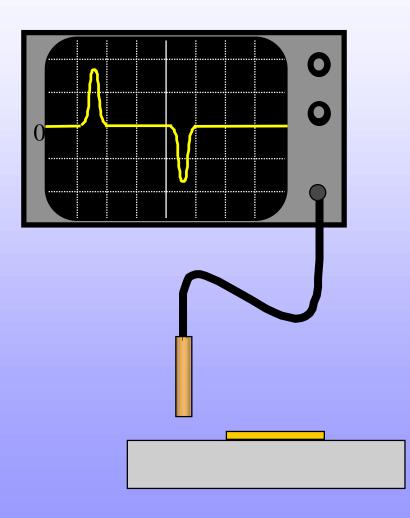












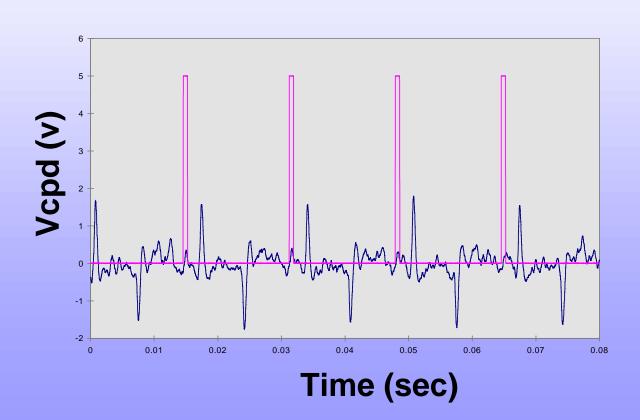
Result - Sample Raw Data

Lubricant Thickness = 20 nm

Probe Height = 0.2 mm

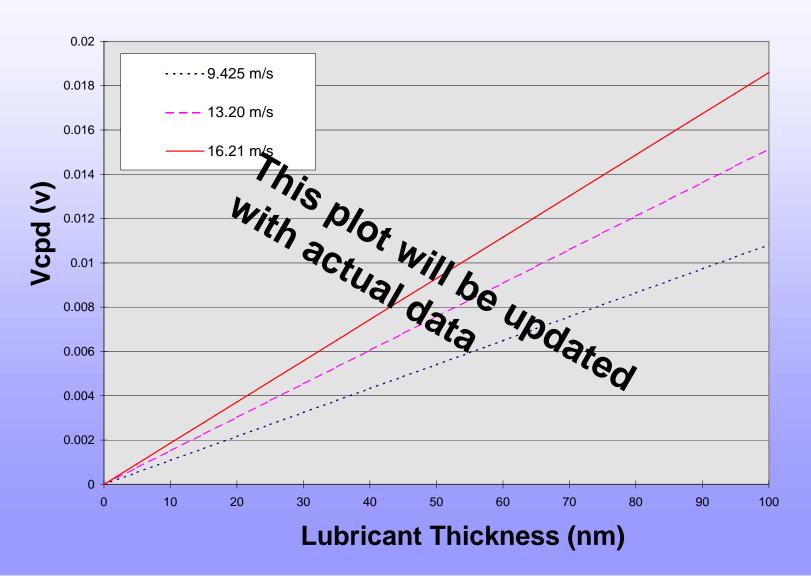


Radial Position: 43 mm



Result





Conclusion/Future Work



CPD probe demonstrated its ability to detect and relate a nano-meter thick lubricant

Future work includes applying this technology to a real-time lubricant condition monitor to a computer hard disk drive